

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/536,037
 Filing Date March 27, 2000
 Inventor Weimin (Michael) Li
 Assignee Micron Technology, Inc.
 Group Art Unit 2822
 Examiner T. Thomas
 Attorney's Docket No. MI22-1398
 Title: Low k Interlevel Dielectric Layer Fabrication Methods



To: Box RCE
 Assistant Commissioner for Patents
 Washington, D.C. 20231

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From: Frederick M. Fliegel, Ph.D.
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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

This Request for Continued Examination (RCE) Application is being filed in an abundance of caution to ensure consideration of the references listed on the attached form PTO-1449.

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether the submitted references are prior art.

Respectfully submitted,

Dated: Nov. 8, 2002

By:


 Frederick M. Fliegel, Ph.D.
 Reg. No. 36,138

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/536,037
Filing Date March 27, 2000
Inventor Weimin (Michael) Li
Assignee Micron Technology, Inc.
Group Art Unit 2822
Examiner T. Thomas
Attorney's Docket No. 1CMI22-1398
Title: Low k Interlevel Dielectric Layer Fabrication Methods



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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

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Washington, D.C. 20231

REMARKS

The Examiner's attention is directed to the reference which is listed on the attached Form PTO-1449 and copy of which is attached. No admission is made regarding whether all the submitted references are prior art.

Citation of this patent is respectfully requested.

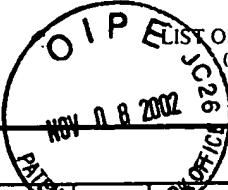
This Information Disclosure Statement is being filed within three months of the filing date of the Request For Continued Examination (RCE) filed August 31, 2001. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this information disclosure statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Respectfully submitted,

Date: Nov 15, 2001

By: Bernard Berman

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200. Form PTO-1449		U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1398	SERIAL NO. 09/536,037		
 LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT Weimin Li et al.					
		FILING DATE March 27, 2000		GROUP 2822			
U. S. PATENT DOCUMENTS							
*Examiner Initial	TRADEMARK OFFICE	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	5,801,399	9/98	Hattori et al.			
	AB	5,994,730	11/99	Shrivastava et al.			
	AC	6,040,619	3/00	Wang et al.			
	AD	6,060,765	5/00	Maeda			
	AE	6,060,766	5/00	Mehta et al.			
	AF	6,133,613	10/00	Yao et al.			
	AG						
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EXAMINER	DATE CONSIDERED
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	